



843.43437X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: TOKUNAGA, et al.

Serial No.: 10/764,563

Filed: January 27, 2004

For: METHOD OF PURGING WAFER RECEIVING JIG, WAFER TRANSFER DEVICE, AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

STATUS LETTER AND REQUEST FOR OFFICIAL FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 29, 2003

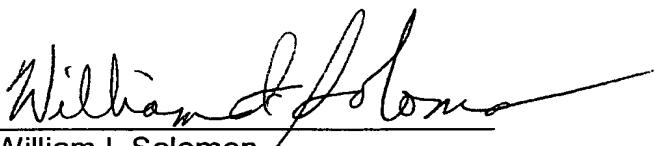
Sir:

Applicants note that the office of the undersigned has not received the Official Filing Receipt for the above-identified application and applicants respectfully request the Official Filing Receipt.

An early response to this request is earnestly solicited.

Respectfully submitted,

Antonelli, Terry, Stout & Kraus, LLP



William I. Solomon
Registration No. 28,565

WIS/rr